Amendments to the Claims:

This listing of claims will replace all prior versions and listing of claims in the application.

Claim 1 is canceled without prejudice or disclaimer.

Claims 2 and 3 are amended.

Listing of Claims:

- 1. (Canceled)
- 2. (Currently Amended) The method according to claim [[1]] 3, wherein the evaporating material cell is of organic electro-luminescent materials.
- 3. (Currently Amended) A method of evaporating thin film used in organic electroluminescent display, comprising steps of:

providing a display substrate;

providing a mask having a phirality of openings and placed below the display substrate; providing a plane evaporation source placed below the mask, wherein the plane evaporation source has a plurality of evaporating material cells arranged in array which are respectively aligned to the openings of the mask; and

evaporating the evaporating material cells to deposit a plurality of thin films on predetermined regions of the display substrate; The method according to claim 1,

wherein the formation of the plane evaporation source comprises steps of: providing a metal plate;

providing at least one kind of evaporation source placed below the metal plate; and

evaporating the evaporation source to form the evaporating material cells on the metal plate.

- 4. (Original) The method according to claim 3, wherein the formation of the plane evaporation source further comprises a step of providing a mask which has a plurality of openings and is disposed between the metal plate and the evaporation source.
- 5. (Original) The method according to claim 3, wherein a plurality of types of evaporation sources are provided below the metal plate.
- 6. (Original) The method according to claim 3, wherein the metal plate is rotated during evaporation.
- 7. (Original) The method according to claim 3, wherein the back side of the metal plate comprises a plurality of supporting ribs.
- 8. (Original) A method of evaporating thin film used in organic electro-luminescent display, comprising steps of:

providing a display substrate;

providing a mask having a plurality of openings and placed below the display substrate;

providing a first plane evaporation source placed below the mask, wherein the first plane evaporation source has a metal net and a plurality of first evaporating material cells which are respectively aligned to the openings of the mask;

providing a second plane evaporation source placed below the first plane evaporation source, wherein the second plane evaporation source has a metal plate and a plurality of second evaporating material cells which are respectively aligned to the openings of the mask; and

evaporating the first evaporating material cells and the second evaporating material cells to deposit a plurality of thin films on predetermined regions of the display substrate.

- 9. (Original) The method according to claim 8, wherein the first evaporating material cell and the second evaporating material cell are of organic electro-luminescent materials.
- 10. (Original) The method according to claim 8, wherein the formation of the first plane evaporation source comprises steps of:

providing the metal net;

providing a first mask which has a plurality of first openings and is placed below the metal net;

providing at least one kind of first evaporation source which is placed below the first mask; and

evaporating the first evaporation source to form the first evaporating material cells on the metal net.

- 11. (Original) The method according to claim 10, wherein the metal net is rotated during evaporation.
- 12. (Original) The method according to claim 10, wherein the back side of the metal net comprises a plurality of supporting ribs.
- 13. (Original) The method according to claim 8, wherein the formation of the second plane evaporation source comprises steps of:

providing the metal plate;

providing a second mask which has a plurality of first openings and is placed below the metal plate;

providing at least one kind of second evaporation source which is placed below the second mask; and

evaporating the second evaporation source to form the second evaporating material cells on the metal plate.

- 14. (Original) The method according to claim 13, wherein the metal plate is rotated during evaporation.
- 15. (Original) The method according to claim 13, wherein the back side of the metal plate comprises a plurality of supporting ribs.